



IR

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chiaki SASAOKA
Title: SEMICONDUCTOR LASER AND METHOD OF
FABRICATING THE SAME
Appl. No.: 10/549,447
Filing Date: 9/14/2005
Examiner: Yuanda Zhang
Art Unit: 2828
Confirmation No.: 5540

AMENDMENT AND REPLY UNDER 37 C.F.R. 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated June 9, 2008 concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 3 of this document.

Please amend the application as follows: